



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kazuhiro HARADA, et al.

Serial No.: 10/769,367

Filed: January 30, 2004

Art Unit: To be Assigned

Examiner: To be Assigned

Attorney Docket No.: JG-SU-5196/500577.20055

Customer No.: 026418

**METHOD OF MANUFACTURING  
SILICON SINGLE CRYSTAL AND  
SILICON SINGLE CRYSTAL  
MANUFACTURED BY THE  
METHOD**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**SECOND PRELIMINARY AMENDMENT**

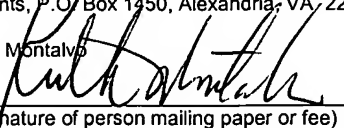
Sir:

The above-identified application is filed concurrently herewith, please amend the specification and claims as follows:

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the Abstract** begins on page 3 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.

CERTIFICATE OF MAILING	
I hereby certify that this paper (along with any document referred to as being attached or enclosed) is being:	
<b>EXPRESS MAIL</b> <input checked="" type="checkbox"/> deposited with the United States Postal Service on August 10, 2005, with sufficient postage as Express Mail, No. EV 398 732 840 US, in an envelope addressed to, Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450. Ruth Montalvo  (Signature of person mailing paper or fee)	<b>FACSIMILE</b> <input type="checkbox"/> transmitted by facsimile on [date] to the U.S. Patent and Trademark Office.  Type Signature Name  (Signature of person mailing paper or fee)